

In the Title:

Please delete the title "Method for Fabrication of Ceramic Tantalum Nitride and Improved Structures Based Thereon" and replace with --Improved Structures Based on Ceramic Tantalum Nitride--.

In the Specification:

β^1 After the title, please insert the sentence: --This is a divisional of application Serial No.

09/512,397 filed February 24, 2000.--

In the Claims:

Please cancel claims 1-6 and 12-20.

Please add the following new claims:

--21. A structure comprising:

β^2 a first capacitor electrode comprising a bottom copper interconnect metal segment;

a first barrier layer over said bottom copper interconnect metal segment;

a copper seed layer over said first barrier layer;

a dielectric comprising tantalum nitride over said copper seed layer;

a second barrier layer over said dielectric;

a second capacitor electrode comprising a top copper interconnect metal